

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Biwa et al.
Appl. No.: Unknown
Conf. No.: Unknown
Filed: Herewith
Title: METHOD OF FABRICATING SEMICONDUCTOR DEVICE AND
SEMICONDUCTOR DEVICE
Art Unit: Unknown
Examiner: Unknown
Docket No.: 112857-347

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT

Sir:

Please amend the above-identified patent application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks begin on page 6 of this paper.